



PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Akio KITAMURA

Serial No.: 10/643,718

Group Art Unit: 2814

Filed: August 19, 2003

Examiner: Weiss, H.

For: METHOD OF MANUFACTURING SEMICONDUCTOR INTEGRATED  
CIRCUIT DEVICE ( As amended)

Certificate of Mailing

I hereby certify that this paper is being deposited  
with the United States Postal Service as first class  
mail in an envelope addressed to: Commissioner  
for Patents, P.O. Box 1450, Alexandria VA 22313-  
1450 on:

Date: 11/08/04

By: [Signature]  
Marc A. Rossi

**AMENDMENT AND REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Official Action dated May 28, 2004, applicants request that the above-identified application be amended as follows.

**Amendments to the specification** begin on page 2 of this paper.

**Amendments to the claims** begin on page 3 of this paper.

**Remarks/arguments** begin on page 7 of this paper.